



**PATENT**  
Attorney Docket No.: SSI-00501

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: ) Group Art Unit: 1763  
Maximilian A. Biberger, *et al.* )  
Serial No.: 09/912,844 ) Examiner: Kackar, Ram N.  
Filed: July 24, 2001 )  
For: **HIGH PRESSURE PROCESSING** ) **TRANSMITTAL LETTER**  
**CHAMBER FOR** )  
**SEMICONDUCTOR SUBSTRATE** )  
)  
)

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Enclosed is an amendment and response to the final office action mailed March 13, 2003 for filing in the U.S. Patent and Trademark Office.

The Commissioner is hereby authorized to charge any additional fee or credit overpayment to our Deposit Account No. 08-1275. **An originally executed duplicate of this transmittal is enclosed for this purpose.**

Respectfully submitted,  
HAVERSTOCK & OWENS LLP

Dated: 5/12/03

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CERTIFICATE OF MAILING (37 CFR § 1.8(a))  
I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Assistant Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

HAVERSTOCK & OWENS LLP.  
Date: 5/12/03 By: J. Corraloca